



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Satoshi INOUE, et al.

Application No.: 10/748,206

Docket No.: 040852.98

Filed: December 31, 2003

For: MANUFACTURING METHOD OF ACTIVE MATRIX SUBSTRATE, ACTIVE MATRIX SUBSTRATE AND LIQUID CRYSTAL DISPLAY

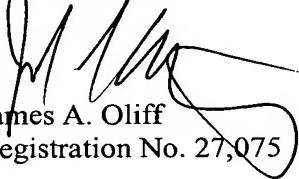
**REQUEST FOR CORRECTION OF PALM RECORDS**

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Sir:

Attached is a photocopy of the original filing receipt on which an error has been corrected in red. This error are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

  
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JAO:JSA/tje

Date: March 22, 2004

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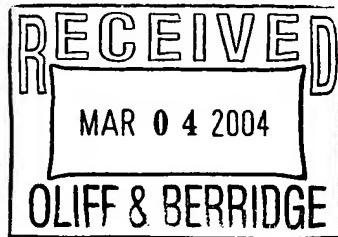
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/748,206	12/31/2003	2812	770	040852.98	27	7	1

25944  
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CONFIRMATION NO. 5363

FILING RECEIPT



\*OC000000011972042\*

Date Mailed: 02/26/2004

Receipt is acknowledged of this reissue Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

**Applicant(s)**

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Suwa-shi

**Domestic Priority data as claimed by applicant**

This application is a DIV of 10/263,070 10/03/2002  
which is a REI of 09/113,373 07/10/1998 PAT 6,127,199  
which is a CIP of PCT/JP97/04110 11/11/1997

**Foreign Applications**

JAPAN 8-315590 11/12/1996  
JAPAN 8-327688 11/22/1996

**Projected Publication Date:** None, application is not eligible for pre-grant publication

**Non-Publication Request:** No

**Early Publication Request:** No

**Title**

Manufacturing method of active matrix substrate, active matrix substrate and liquid crystal display

device

**Preliminary Class**

438

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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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